

Atmospheric pressure plasma jet generation and impedance measurement

Speaker : 李鉞 Li Jia (Tokyo Tech)

Supervisor : Prof. Lawrence Overzet

University of Texas at Dallas



CONTENTS:

- 1. Introduction**
 - Dallas
 - UTD (University of Texas at Dallas)
 - ITP (International Training Program)
- 2. Background → CAPPJ (Cold Atmospheric Pressure Plasma Jet)**
- 3. APPJ (Atmospheric Pressure Plasma Jet) generation**
- 4. Electrode configuration**
- 5. Impedance measure**
- 6. Calculation principle**
- 7. Results**
 - Plume length
 - Waveforms
 - Measurement
- 8. Summary & Future work**
- 9. Learn from UTD**

Location in Dallas County and the state of Texas



Flag of Dallas



Seal of Dallas

Location in the United States

Coordinates:  **32°46'58"N 96°48'14"W**

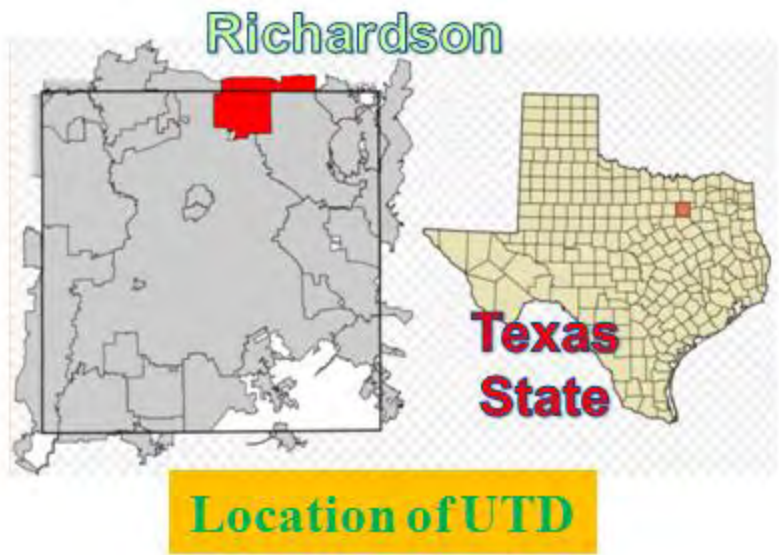


Place of interest

Most famous: sixth floor museum

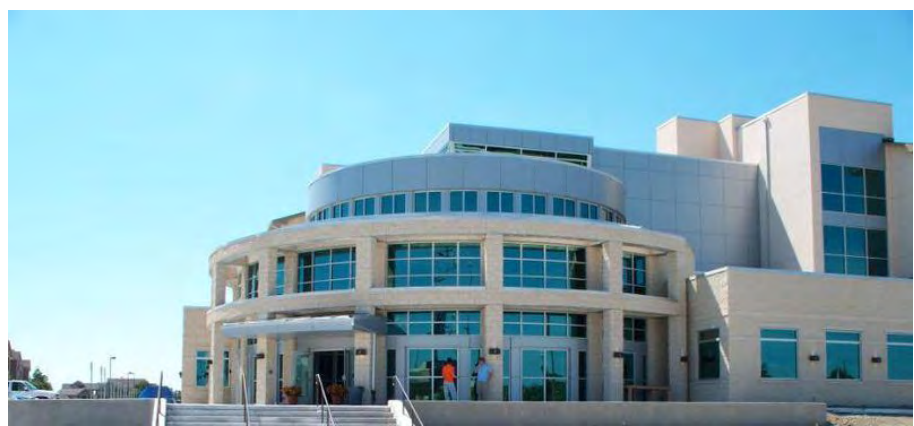
About the city of Dallas

- 3rd largest city in Texas State
- 8th largest city in the United States
- Population ~ 1.4 million by Jan. 1, 2010
- A humid subtropical climate
 - hot, humid summers
 - cool winters
- Primary airport → DFW airport



University of Texas at Dallas

- A public research university in The University of Texas System.
- The UTD main campus is located in Richardson, Texas, United States
- Is best known for its computer science, natural science, engineering, cognitive science, mathematics, and MBA programs



UTD Residence Hall



UTD Library

International Training Program

- **Period:** 2 months → Jan.9 --- Mar. 9, 2010
 - **Research site:** NSERL → Natural Science and Engineering Research Laboratory
3rd floor
Prof. Lawrence Overzet
Plasma Science and Applications Lab.
 - **Living site:** dormitory → UTD Apartments furnished 2-bed room
(shared with an Indian) A 10 minute walk to Lab.
- Dining site:** dining hall on the campus
or cook by yourself (30 min. walk to super market)



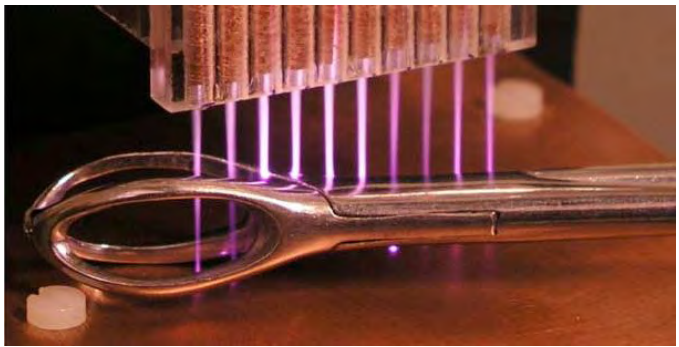
UTD Apartments



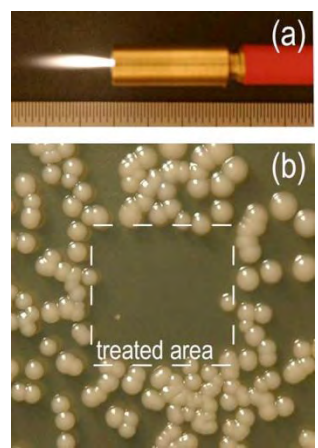
Natural Science and Engineering Research Laboratory

CAPPJ: Cold Atmospheric Pressure Plasma Jet

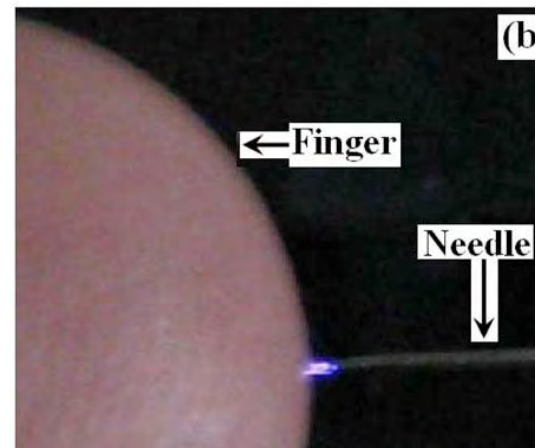
- *Cheaper & more convenient* than low-pressure plasmas
- *Simple* configurations & *easy* operation



Appl. Phys. Lett. 94, 021501 2009



Appl. Phys. Lett. 92, 241501 2008



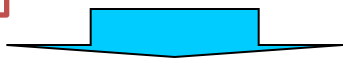
Appl. Phys. Lett. vol. 95, no. 18, pp. 3, 2009

Treatment

- 3-D objects
- thermally sensitive materials

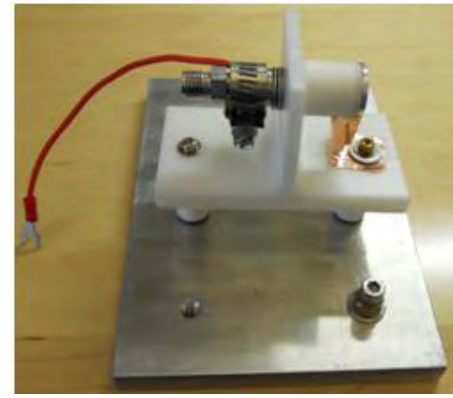
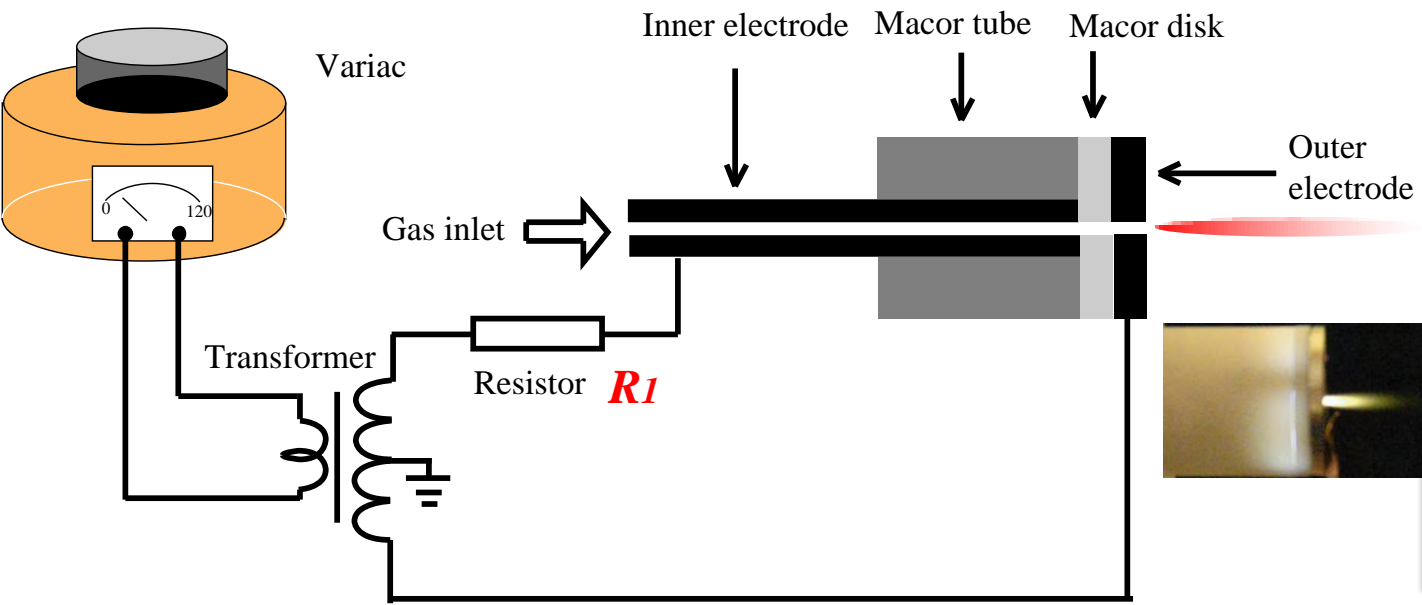


Biomedical applications



Research objective:
Find an easy way to generate N₂ APPJ and try to measure plasma impedance

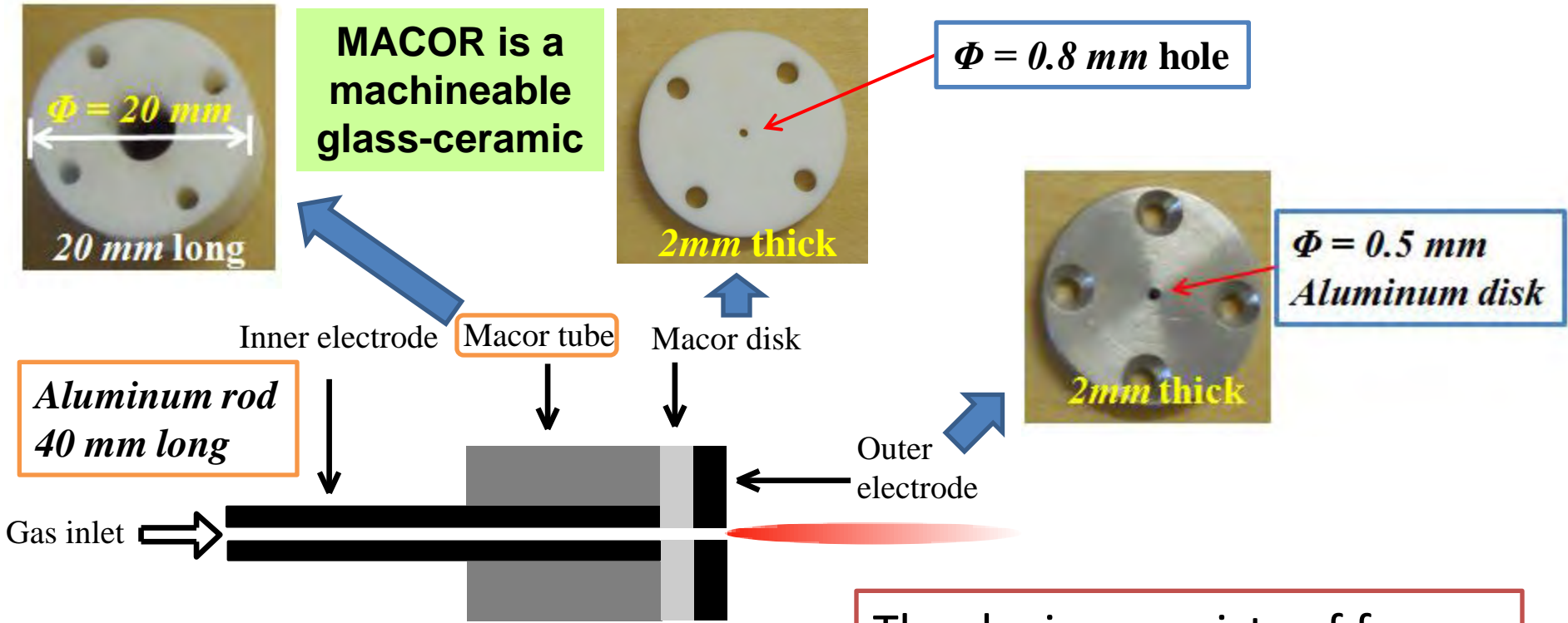
Schematic of the experimental setup



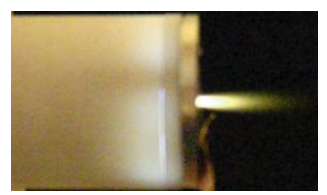
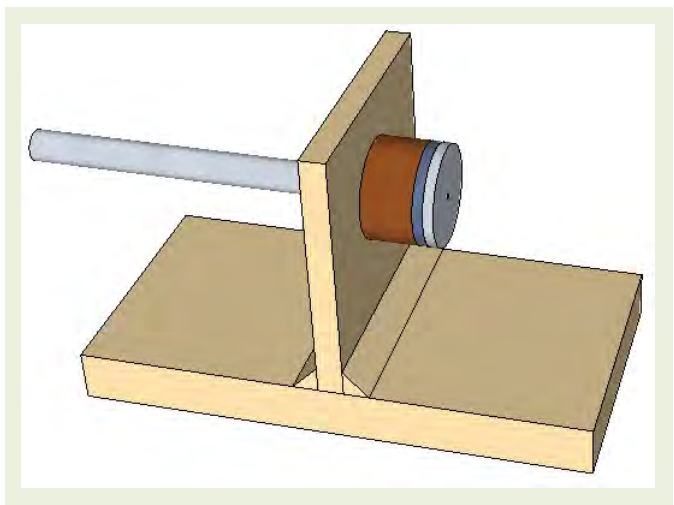
↓
 Design & manufacture cost ~ one month

1. Variac: POWERSTAT: output voltage ~ 120 V
2. Transformer: Transformer $V_{p-p} \sim 6\sqrt{2}$ kV, $f \sim 60$ Hz
 a step-up transformer for neon light
3. Gas: N₂

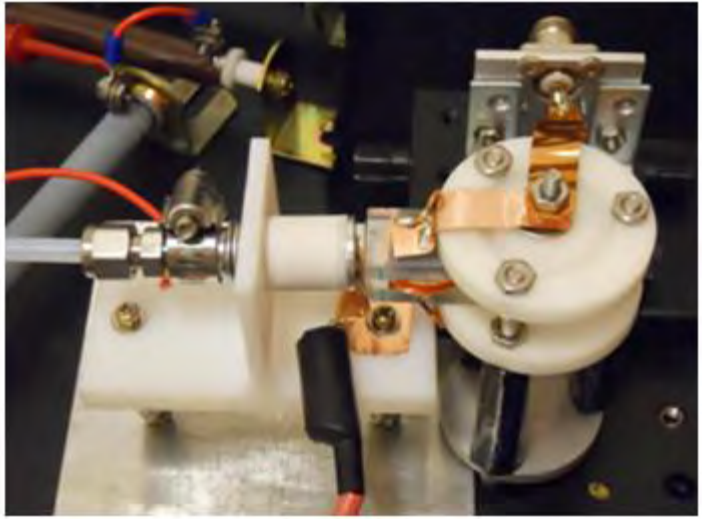
1. All of these are **easy** to get!
2. **Simple** to generate plasma



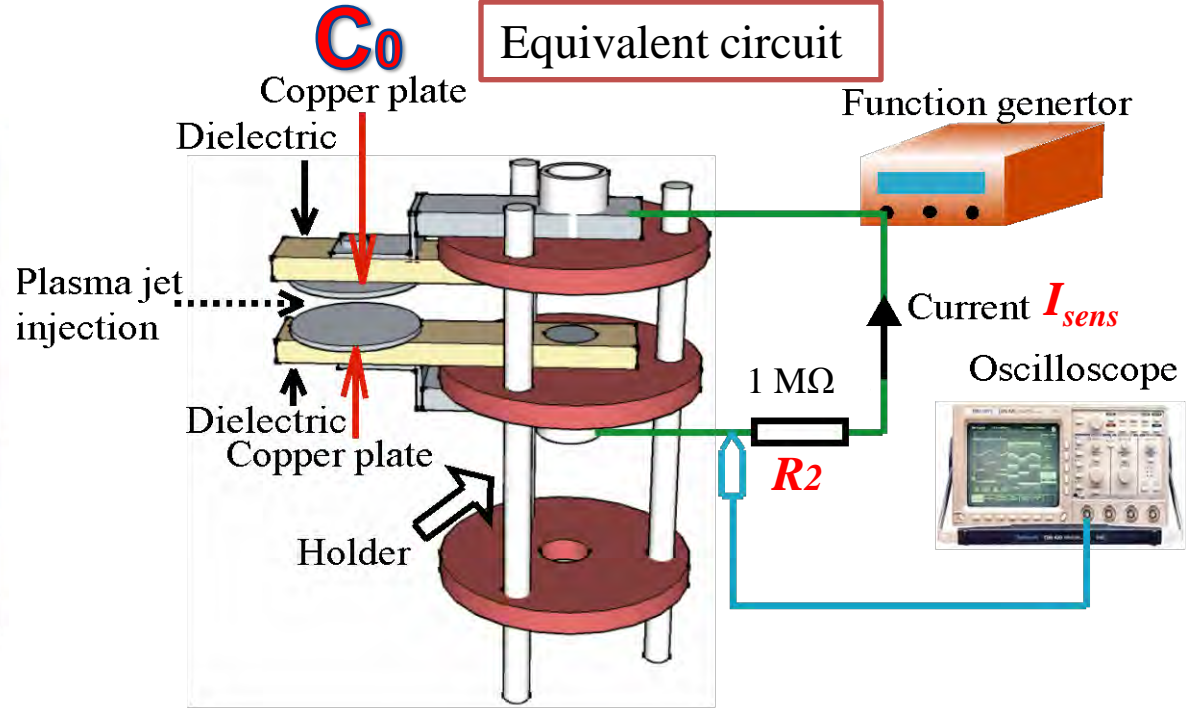
- The device consists of four parts:
- Inner electrode
 - Outer electrode
 - MACOR tube
 - MACOR disk (dielectric)



Photograph



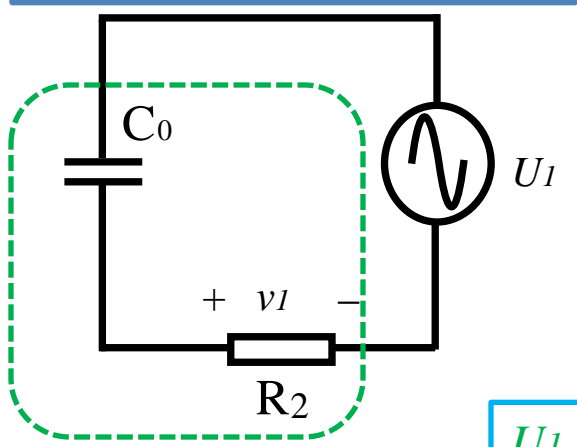
Equivalent circuit



To avoid the errors from sheath effect, we measure the plasma plume impedance by:

- 1 Function generator (Tektronix CFG250) → Sinusoidal voltage signal ($f \sim 175 \text{ kHz}$, $U_{p-p} \sim 10 \text{ V}$)
- 2 The flowing current I_{sens} is obtained by measuring the voltage across $1 \text{ M}\Omega$ resistor
- 3 The current variation before and after plasma injection can be used to calculate plasma plume impedance

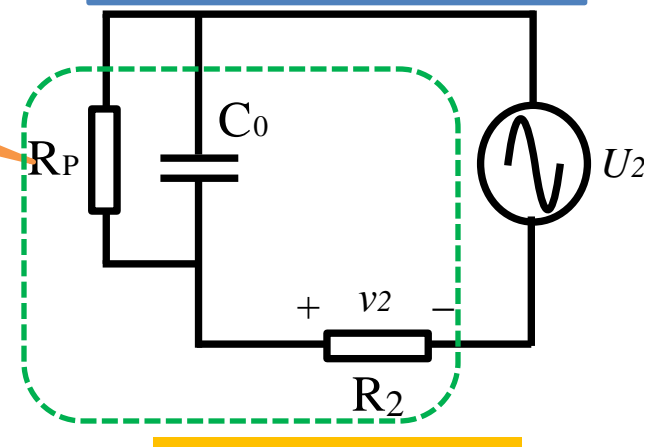
Without plasma injection



Impedance: Z_{off}

Plasma resistance?

With plasma injection



Impedance: Z_{on}

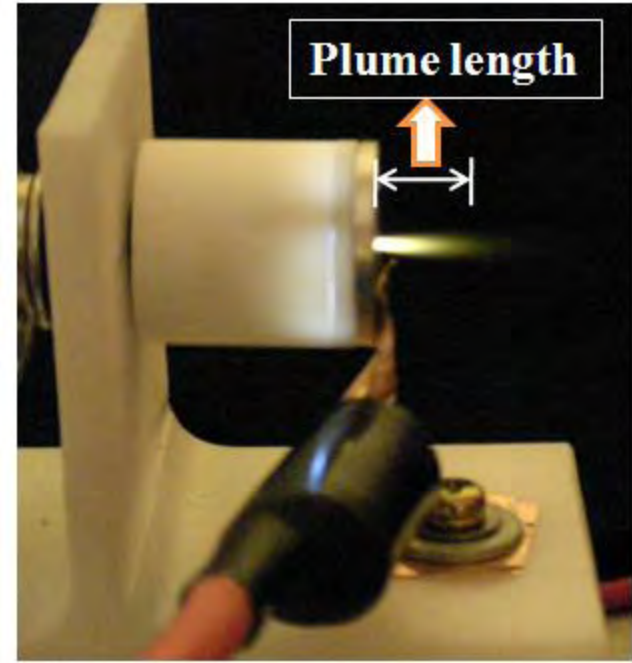
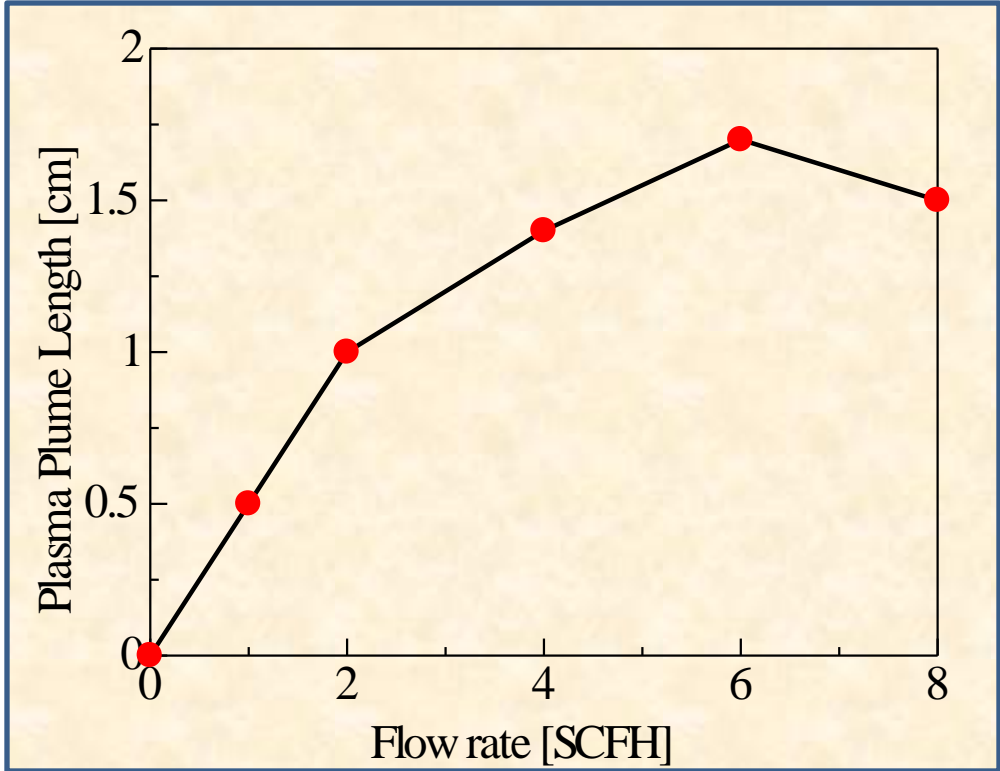
U_1 U_2 : Output voltage from function generator

$$U_1 = \frac{v_1}{R_2} Z_{off} = \frac{v_1}{R_2} \sqrt{R_2^2 + \frac{1}{\omega^2 C_0^2}} \quad \text{Ohm's law} \quad U_2 = \frac{v_2}{R_2} Z_{on} = \frac{v_2}{R_2} \sqrt{R_2^2 + \frac{2R_2 R_p + R_p^2}{R_p^2 \omega^2 C_0^2 + 1}}$$

$$U_1 = U_2 \Rightarrow \underbrace{\left(1 - \frac{v_1^2}{v_2^2}\right) \left(1 + R_2^2 \omega^2 C_0^2\right) R_p^2 + 2R_2 R_p}_a - \underbrace{\left[\left(\frac{v_1}{v_2}\right)^2 \left(R_2^2 + \frac{1}{\omega^2 C_0^2}\right) - R_2^2\right]}_c = 0$$

$$R_p = \frac{-b + \sqrt{b^2 - 4ac}}{2a}$$

Dependence of visible jet length on N₂ flow rate. $V_{p-p} \sim 5\sqrt{2}$ kV



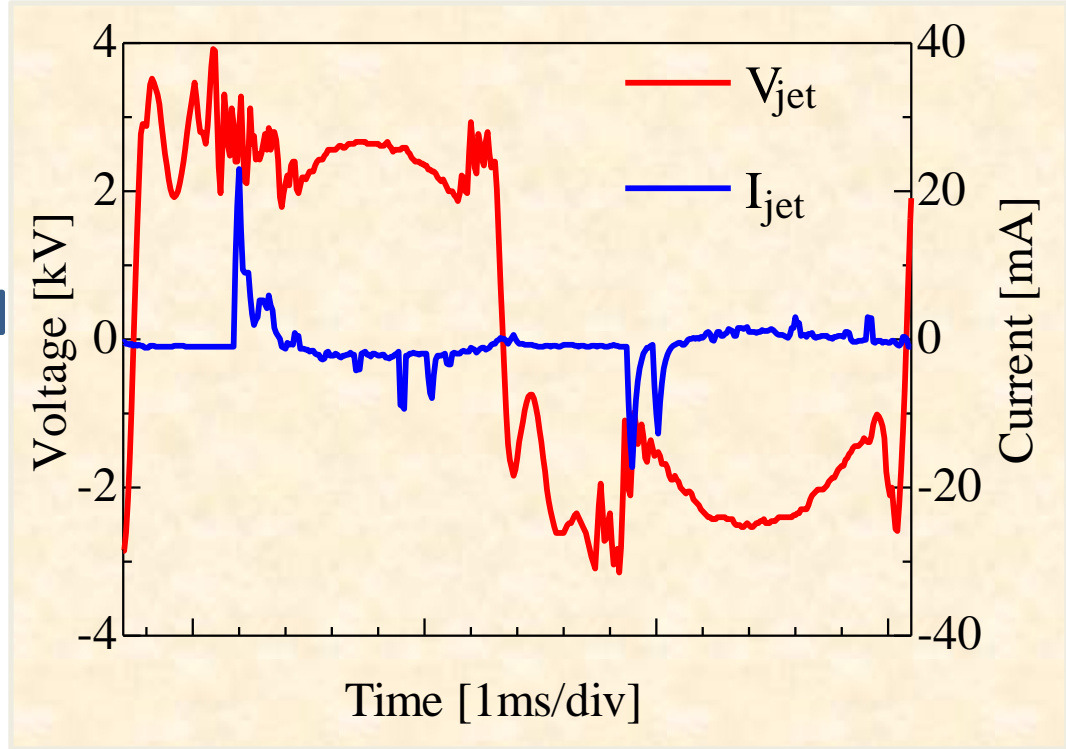
Reynolds number (Re) in the N₂ plasma jet device is estimated to be about 7.7×10^3 showing a turbulent flow

$$Re = \frac{D \cdot v \cdot \rho}{\mu}$$

A maximum length of 1.7 cm is obtained with a flow rate of 6 SCFH (2.8 l/m)

V-I waveforms of plasma jet: N₂ 6 SCFH; $V_{p-p} \sim 5\sqrt{2}$ kV

Discharge Voltage V_{jet}

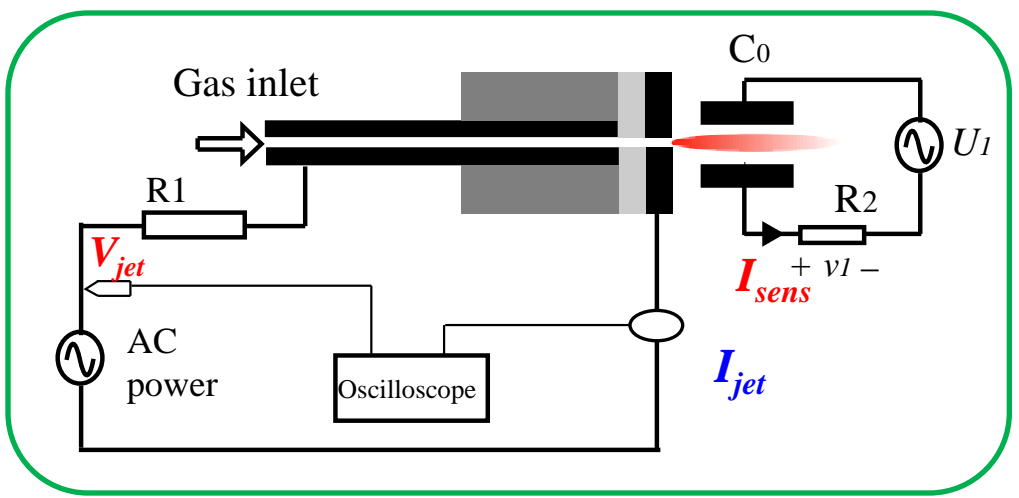
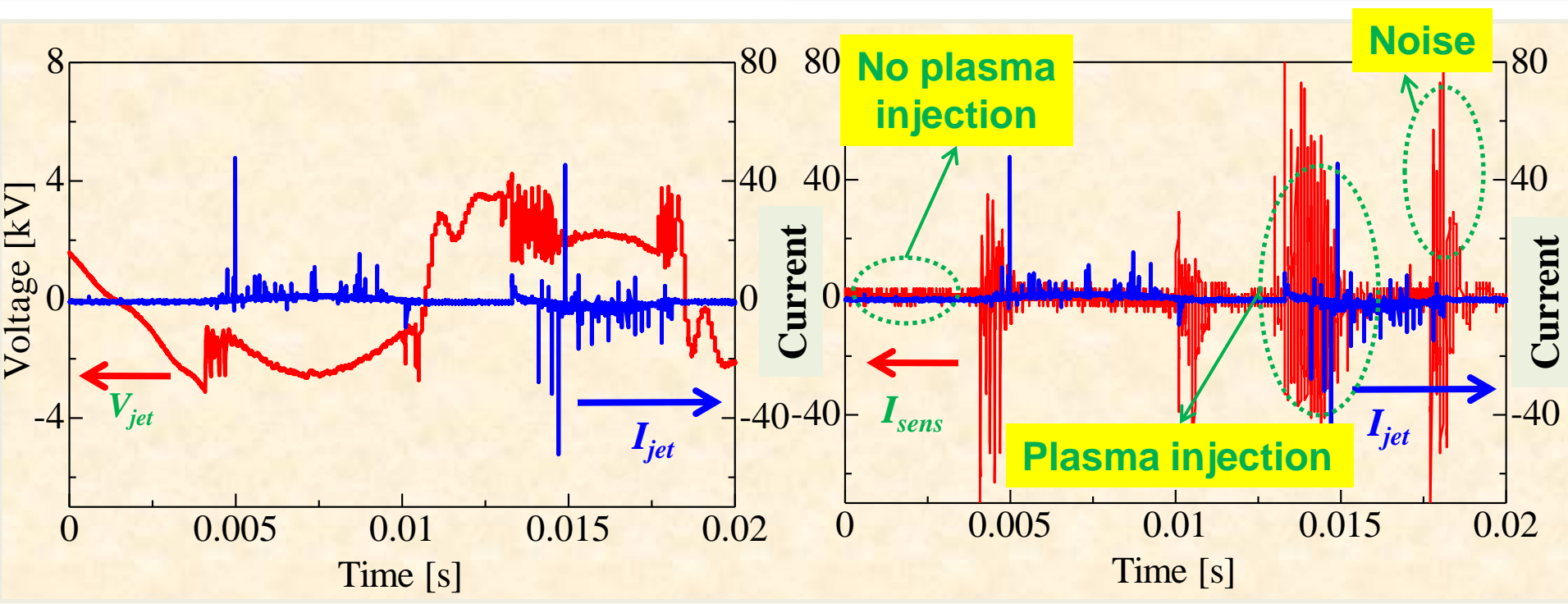


Discharge Current I_{jet}

- Like pin-to-plate discharge, the current spikes erratically appear on the temporal abscissa (axis of Time)
- The average duration of these current pulses is only about hundreds of ns

Arc-similar discharge → High speed flowing gas cools the plasma jet

Result 3: Measurement



- I_{sens} changes after plasma injection
- ➔ Possible to calculate R_p
- Obvious noise is seen
- ➔ Need improving

Summary

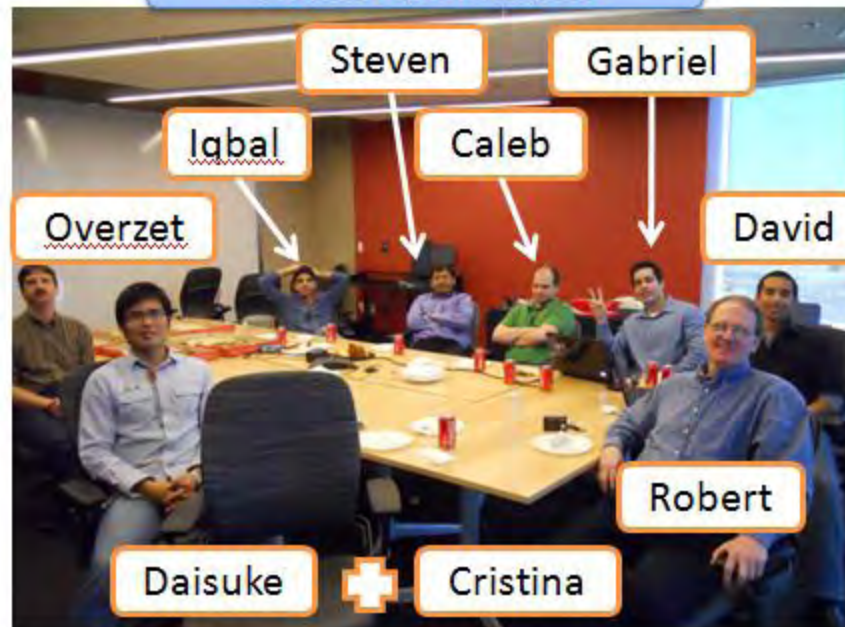
- A plasma jet at atmospheric pressure using N_2 was designed and generated
- The plasma plume with a maximum length of ~ 2 cm can be produced by AC power for N_2
- A possible method was proposed and used to measure plasma impedance (because of short time, only the feasibility is confirmed)

Next Work

1. To generate air plasma jet: better transformer...
2. To investigate detailed characteristics:
discharge power, temperature...
3. Improve the measurement

Experience the different research atmosphere in UTD

Seminar Room



Make the best of seminar:

1. A place to learn, not just listen
2. Raise questions
3. Keep track of what the others do

To communicate with Prof. effectively

1. In UTD, > 2 times per week
2. How to discuss with Prof. effectively:
problem → **your own solution** →
bad result → talk to Prof. ...

Thanks for attention!